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ventor Kunal R. Parekh et al.
ssignee Micron Technology, Inc.
riority Group Art Unit
riority Examiner Y. Huynh
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tle: Capacitors, DRAM Arrays, Monolithic Integrated Circuits, And Methods of Forming
Capacitors, DRAM Arrays, And Monolithic Integrated Circuits

INFORMATION DISCLOSURE STATEMENT

References - - See attached Form PTO-1449

In compliance with 37 C.F.R. §§ 1.56, 1.97 and 1.98, your attention is directed to the United States patents and other references listed on the attached Form PTO-1449. No admission is made regarding whether all the submitted references are prior art.

The listed references were cited by, or submitted to, the Office in the parent, copending application of the above-identified application. The above-identified application is a continuation application of co-pending application Serial No. 09/765,510, filed January 19, 2001, upon which the above-identified application relies for a priority date under 35 U.S.C. §120. Such prior disclosure is sufficient for the above-identified application as far as copies of the references are concerned. 37 C.F.R. §1.98(d) and MPEP §609(2). As a courtesy, Applicant submits copies of the cited references for review.

Citation of these references is respectfully requested.

Respectfully submitted,

Date: 5-47. (8,200)

Frederick M. Fliegel, Ph.D.

Reg. No. 36,138